DERWENT-ACC-NO: 1985-267018

DERWENT-WEEK: 198543

COPYRIGHT 1999 DERWENT INFORMATION LTD

TITLE: Microwave switch with piezoelectric device - has

two lever arms

flexible beam member and transmitting spring NoAbstract Dwg

0/4

. A .,

PATENT-ASSIGNEE: NEC CORP[NIDE]

PRIORITY-DATA: 1984JP-0036818 (February 27, 1984)

PATENT-FAMILY:

PUB-NO PUB-DATE LANGUAGE

PAGES MAIN-IPC

JP 60180036 A September 13, 1985 N/A

006 N/A

APPLICATION-DATA:

PUB-NO APPL-DESCRIPTOR APPL-NO

APPL-DATE

JP 60180036A N/A 1984JP-0036818

February 27, 1984

INT-CL (IPC): H01H057/00

ABSTRACTED-PUB-NO: EQUIVALENT-ABSTRACTS:

TITLE-TERMS:

MICROWAVE SWITCH PIEZOELECTRIC DEVICE TWO LEVER ARM

FLEXIBLE BEAM MEMBER

TRANSMIT SPRING NOABSTRACT

DERWENT-CLASS: V03

EPI-CODES: V03-D05;

CLIPPEDIMAGE= JP401217982A

PAT-NO: JP401217982A

DOCUMENT-IDENTIFIER: JP 01217982 A

TITLE: PIEZOELECTRIC LINEAR ACTUATOR

PUBN-DATE: August 31, 1989

INVENTOR-INFORMATION:

NAME

TAKAHARA, KENICHI

ASSIGNEE-INFORMATION:

NAME

TOSHIBA CORP

COUNTRY

N/A

APPL-NO: JP63042375

APPL-DATE: February 26, 1988

INT-CL (IPC): H01L041/08

ABSTRACT:

PURPOSE: To obtain a piezoelectric linear actuator which requires only ordinary accuracy of mechanical working, allows gaps to be regulated easily, is operable with larger strokes and alleviates limits of loads, by providing a plurality of clamp arms for constituting a clamp section, so that displacement of a clamp piezoelectric element is amplified by these clamp arms to be utilized for clamping an object to be clamped.

CONSTITUTION: A flexible hinge 13 having constricted profile is provided close to and on the upper side of a hinge 14 of each of clamp arms 6a-6c and 11a-11c.

One end of each of clamp piezoelectric elements 5a-5c is secured thereto while the other end is secured to a flange 29 formed on the outer periphery of

movable bases 7, 9. A rotating radius between the hinges 13, 14 is shorter

than a rotating radius between the hinge 14 and a clamp pad 16 of each clamp

arm. Accordingly, when the piezoelectric element is extended in the directions

as indicated by the arrows, force is applied to the upper hinge 13 serving as a

force point, and the distal end of the clamp arm is rotated round the fulcrum,

that is the lower hinge 14 at the proximal end of the clamp arm, and pressed

against the outer peripheral surface of a shaft 10 to clamp the same.

COPYRIGHT: (C) 1989, JPO&Japio

CLIPPEDIMAGE= JP402218579A

PAT-NO: JP402218579A

DOCUMENT-IDENTIFIER: JP 02218579 A

TITLE: CHUCK USING LAMINATION TYPE PIEZOELECTRIC CERAMICS

PUBN-DATE: August 31, 1990

INVENTOR-INFORMATION:

NAME

YAMAUCHI, MASAYOSHI MINEGISHI, KEIICHI

ASSIGNEE-INFORMATION:

NAME

SMC CORP

COUNTRY

N/A

APPL-NO: JP01039532

APPL-DATE: February 20, 1989

INT-CL (IPC): B25J015/00; B23Q007/04; B25J019/00

ABSTRACT:

PURPOSE: To miniaturize a chuck and to easily control the displacement amount of an arm, in other words the holding force of a work by constituting so as to drive a pair of the arms holding the work by a lamination type piezoelectric

ceramics.

CONSTITUTION: When voltage is impressed on a lamination type piezoelectric

ceramics 2, the lamination type piezoelectric ceramics 2 is displaced

analogically according to the impressed voltage to press the base parts 4a, 5a

medium of a pair of arms 4, 5. In this case, the opposed arms side of the base

parts 4a, 5a of the arms 4, 5 are rockably linked to a support base 3 by hinge

parts 6, 7 respectively. So that, a pair of the arms 4, 5

01/31/2003, EAST Version: 1.03.0002

are turned in the direction that the gap of between mutual arms becomes narrow by the hinge parts 6, 7. Consequently, a desired work can be held by a pair of the arm 4 and 5 with the lamination type piezoelectric ceramics 2 as the power source, the displacement amount of the arms 4, 5, in other words the holding force of the work can be controlled by the high and low of the impressing voltage, and so the control is easy.

COPYRIGHT: (C) 1990, JPO& Japio

CLIPPEDIMAGE= JP410248278A

PAT-NO: JP410248278A

DOCUMENT-IDENTIFIER: JP 10248278 A

TITLE: DRIVING DEVICE USING ELECTROMECHANICAL TRANSDUCER

ELEMENT

PUBN-DATE: September 14, 1998

INVENTOR-INFORMATION:

NAME

YOSHIDA, RYUICHI OKAMOTO, YASUHIRO ARAYA, SATOSHI NAKANO, HARUYUKI

ASSIGNEE-INFORMATION:

NAME

MINOLTA CO LTD

COUNTRY

N/A

APPL-NO: JP09061698

APPL-DATE: March 3, 1997

INT-CL (IPC): H02N002/00

ABSTRACT:

PROBLEM TO BE SOLVED: To provide a driving device using an electromechanical transducer element, in which there is no risk of the damage of the driving device and a driven member even when unintentional external force is applied to the device.

SOLUTION: In the driving, in which a slider block 31 is coupled frictionally with a driving shaft 16 reciprocated and vibrated by displacement by the expansion and contraction of a piezoelectric element 39, constitution, in which the slider block 31 is fixed onto the driving shaft 16 at the stoppage of

driving, is formed. That is, an arm member 38 is combined with a hinge section

34 by a hinge section 38a, and the piezoelectric element 39 is arranged between

a forked member 32 and the arm member 38. When the slider block 31 is fixed

onto the driving shaft 16, voltage is applied to the piezoelectric element 39,

and the displacement of elongation is generated in the thickness direction.

Accordingly, bonding sections 32a, 33a of the forked member 32 are brought into

press-contact firmly with the driving shaft 16, and the slider block 31 can be fastened onto the driving shaft 16.

COPYRIGHT: (C) 1998, JPO

| | Туре | L # | Hits | Search Text | DBs | Time Stamp | Comment s |
|---|------|-----|------|---|--|----------------------|--------------|
| 1 | BRS | L1 | 11 | piezoelectric adj1 stack same adjust\$4 adj2 (screw or bolt\$3) | USPA T; US-P GPUB; EPO; JPO; DERW ENT; IBM TDB | 2003/01/3 1 09:33 | |
| 2 | BRS | L2 | 0 | piezoelectric adj1 stack same adjust\$4 adj2 (screw or bolt\$3) | | 2003/01/3 1 09:40 | |
| 3 | BRS | L3 | 16 | piezoelectric adj1 stack and adjust\$4 adj2 (screw or bolt\$3) and (preload or pre adj1 load) | USPA T; US-P GPUB ; EPO; JPO; DERW ENT; IBM_ TDB | 2003/01/3 1 09:41 | |

| | | | | | | - | | |
|---|------|----|---|------|---|--|----------------------|--------------|
| | Type | L | # | Hits | Search Text | DBs | Time Stamp | Comment s |
| 1 | IS&R | L1 | | 1359 | (310/328).CCLS. | USPA T | 2003/01/3 1 06:34 | |
| 2 | IS&R | L2 | | 228 | (310/328).CCLS. | US-P GPUB; EPO; JPO; DERW ENT; IBM_ TDB | 2003/01/3 1 06:42 | |
| 3 | BRS | L3 | | 726 | (piezoelectric or electrostrictive or electromechanical) same arm same (flex\$4 or pivot\$4) | 1 | 2003/01/3 1 06:53 | |
| 4 | BRS | L4 | | 37 | (piezoelectric or electrostrictive or electromechanical) same arm same (flex\$4 or pivot\$4 or hinge\$4) not 13 | | 2003/01/3 1 06:55 | |
| 5 | BRS | L5 | | 358 | (piezoelectric or electrostrictive or electromechanical) same arm same (flex\$4 or pivot\$4 or hinge\$4) | US-P GPUB; EPO; JPO; DERW ENT; IBM_ TDB | 2003/01/3 1 06:55 | |